



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Smith, *et al.* Docket No.: 2001 P 11900 US01  
Serial No.: 10/786,996 Art Unit: 1746  
Filed: February 25, 2004 Examiner: Markoff, Alexander  
For: Method of Removing PECVD Residues of Fluorinated Plasma Using In-Situ  
H<sub>2</sub> Plasma

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08B that may be considered material to the examination of the above-identified application.

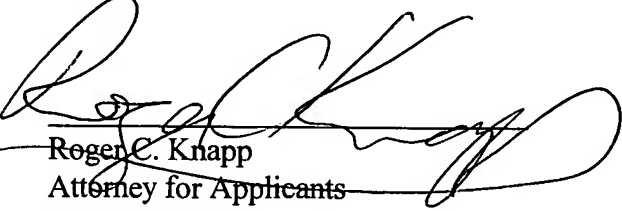
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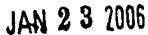
01/24/2006 SFELEKE1 00000009 501065 10786996  
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January 20, 2006  
Date

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

***(Use as many sheets as necessary)***

Sheet

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of

1

## Application Number

10/786,996

Filing Date

February 25, 2004

**First Named Inventor**

Smith, et al.

**Art Unit**

1746

**Examiner Name**

**Markoff, Alexander**

Attorney Docket Number

2001 P 11900 US01

Examiner  
Initials\*Cite  
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Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.

 $T^2$ 

1

SMITH, Bradley C., *et al.*, "Optimizing Chamber Cleans for Better Film Deposition Performance," *Journal of the Electrochemical Society*, Vol. 148, No. 11 (2001) pp. C721-C725.

2

PEARTON, S.J., *et al.*, "Dry Surface Cleaning of Plasma-Etched HEMT's," Mat. Res. Soc. Symp. Proc., Vol. 282 (1993) pp. 131-138.

**Examiner  
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Date \_\_\_\_\_

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